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For PTO-1449 (Modified)

# IST OF PATENTS AND PUBLICATIONS FOR APPLICANT'S INFORMATION DISCLOSURE STATEMENT

(Use several sheets if necessary)

Atty Docket No.	Serial No.
RAYTP0227US	10/723,337
Applicant:	
Hatfield, et al.	_
Filing Date	Group
11/26/2003	

**U.S. PATENT DOCUMENTS** 

Examiner Initial	Document Number	Date (MMYYYY)	Name	Class	Sub- class	Filing Date if Appropriate
NJ	5,710,418	1/1998	Masami Tawara			
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#### FOREIGN PATENT DOCUMENTS

	Examiner	Document Number	Date (MM/YYYY)	Country	Class	Sub- class	Translation	
1	Initial						Yes	No
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## OTHER ART

Examiner Initial	Author, Title, Date, Pertinent Pages, etc.	
NJ	See attached	

EXAMINER /Nithya Janakiraman/ DATE CONSIDERED 12/21/2006

EXAMINER:

Initial if reference considered, whether or not citation is in conformance with MPEP 609; Draw line through citation if not in conformance and not considered. Include copy of this form with next communication to applicant.

### Information Disclosure Statement PTO-1449 (Modified)

The identification of any reference is not intended to be, and should not be understood as being, an admission that such publication, in fact, constitutes "prior art" within the meaning of applicable law since, for example, a given reference may have a later effective date than first seems apparent or the reference may have an effective date which can be antedated. The "prior art" status of any reference is a matter to be resolved during prosecution. R:\Ken\Raytheon\RaythP0227US\IDS.frm (IDS1449.FRM) (2/97)

<u>Author</u>	<u>Title</u>	<u>Date</u>	Pertinent Page
H.T. Yura and S.G. H	"Effects of receiver optics contamination or the performance of laser velocimeter systems"	Sept. 1996	Vol. 13, No. 9
Patrick H. Schnabel & Patricia M. Lindley (C Evans & Associates a David Nehrkorn & Ma Kendall (Surface Scie Laboratories	of Airborne Molecular ius Contamination: A Multi-		Semiconductor Fabtech - 11 <sup>th</sup> Edition
Mikael Forsland & Se OReilly	"Prevention of Airborne Molecular Contamination"		Semiconductor Fabtech - 12 <sup>th</sup> Edition

Form PTO-1449 (Modified) LIST OF PATENTS AND PUB FOR APPLICATION INFORMATION DISCLOSURE (Use several sheets if necessary)

Atty Docket No.	Serial No.
RAYTP0227US	10/723,337
Applicant:	
Hatfield et al.	
Filing Date	Group
November 26, 2003	2123

**U.S. PATENT DOCUMENTS** 

Examiner Initial	Document Number	Date	Name	Class	Sub- class	Filing Date if Appropriate
NJ	2003/068834 A1	04/10/2003	Kishkovich et al.			
NJ	6,046,451 A	04/04/2000	Sinha et al.			
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Examiner	Document Number	t Number Date Country	Class	Sub-	Transla	ition		
Initial					class	Yes	No	
ŊJ	2002-168776	14/06/2002	JP			Abstr	Abstract	
NJ	2001-110698 A	20/04/2001	JP			Abstract		
NJ	0 710 830 A	08/05/1996	EP					

#### OTHER ART

Examiner Initial	Author, Title, Date, Pertinent Pages, etc.
ŊJ	International Search Report regarding Application No. PCT/US2004/035787 mailed February 24, 2005.

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	EXAMINER	/Nithya Janakiraman/	DATE CONSIDERED	12/21/2006	
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